

Electronic Patent Application Fee Transmittal

Application Number:	10081385			
Filing Date:	20-Feb-2002			
Title of Invention:	Film thickness measuring method and apparatus, and thin film device manufacturing method and manufacturing apparatus using same			
First Named Inventor/Applicant Name:	Takenori Hirose			
Filer:	Jesus Del Castillo/Gloria Sikora			
Attorney Docket Number:	16869P-042900US			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Petition fee- 37 CFR 1.17(h) (Group III)	1464	1	130	130
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 2 months with \$0 paid	1252	1	450	450
Miscellaneous:				
Total in USD (\$)				580